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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yi-Ming Sheu

Serial No.: 10/619,114

Filed: 07/14/2003

For: NARROW WIDTH EFFECT
IMPROVEMENT WITH PHOTORESIST PLUG
PROCESS AND STI CORNER ION
IMPLANTATION

)
)
) Group Art Unit: 2823
)
) Examiner: Brewster, William
)
) Confirmation No.: 6852
)
) TKHR Docket: 252016-1300
) Top-Team Dkt: 0503-9540US
)

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on August 2, 2005.


Signature – Hui Chin Barnhill

RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed May 17, 2005 has been carefully considered. In response thereto, please consider the following remarks.